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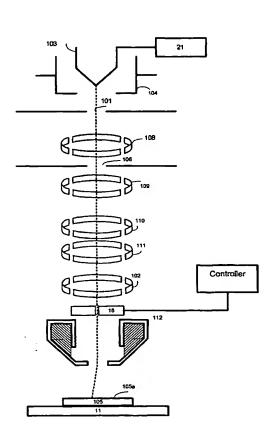
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[Continued on next page]

(54) Title: A METHOD FOR MEASURING AND REDUCING ANGULAR DEVIATIONS OF A CHARGED PARTICLE BEAM



(57) Abstract: The invention provides a system and method for determining an angular deviation of a charged particle beam and for calibrating a charged particle beam system that are based upon multiple measurements of a test object that include sidewalls of high sidewall angle uniformity. A path of a charged particle beam is controlled by multiple beam control parameters. The method determines the parameters that will substantially reduce the angular deviation and applies them in order to calibrate a charged particle beam system.

CU, CZ, DE, DK, DM, DZ, EC, EE, EG, ES, FI, GB, GD, GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE, KG, KP, KR, KZ, LC, LK, LR, LS, LT, LU, LV, MA, MD, MG, MK, MN, MW, MX, MZ, NI, NO, NZ, OM, PG, PH, PL, PT, RO, RU, SC, SD, SE, SG, SK, SL, SY, TJ, TM, TN, TR, TT, TZ, UA, UG, US, UZ, VC, VN, YU, ZA, ZM, ZW.

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A. CLASSIFICATION OF SUBJECT MATTER 1PC 7 G01N23/225 H01J37/304

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols) $IPC \ 7 \ GO1N \ HO1J$

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the international search (name of data base and, where practical, search terms used)

EPO-Internal, PAJ, INSPEC, WPI Data

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Y	page 5, line 31 - line 35 page 8, line 9 - line 20; figures 1,2	41,46-50	
A	US 6 472 662 B1 (ARCHIE CHARLES NEILL) 29 October 2002 (2002-10-29) cited in the application column 3, line 12 - line 44 column 5, line 21 - column 39	1-39, 51-67	
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Further documents are listed in the continuation of box c.	A Patent family members are used in and by.
"A" document defining the general state of the art which is not considered to be of particular relevance "E" earlier document but published on or after the international filling date "L" document which may throw doubts on priority claim(s) or which is cited to establish the publication date of another citation or other special reason (as specified) "O" document referring to an oral disclosure, use, exhibition or other means "P" document published prior to the international filling date but later than the priority date claimed	"T" later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention. "X" document of particular relevance; the claimed invention cannot be considered novel or cannot be considered to involve an inventive step when the document is taken alone. "Y" document of particular relevance; the claimed invention cannot be considered to involve an inventive step when the document is combined with one or more other such documents, such combination being obvious to a person skilled in the art. "&" document member of the same patent family
Date of the actual completion of the international search 20 August 2004	Date of mailing of the international search report 0 1, 09, 2003
Name and mailing address of the ISA European Patent Office, P.B. 5818 Patentlaan 2 NL ~ 2280 HV Rijswljk Tel. (+31~70) 340~2040, Tx. 31 651 epo ni, Fax: (+31-70) 340~3016	Authorized officer Wulveryck, J-M



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Category °	ation) DOCUMENTS CONSIDERED TO BE RELEVANT Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
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Υ	TESTING) 31 October 2001 (2001-10-31) column 2, line 53 - column 3, line 10	44,45 41,46-50
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A	PATENT ABSTRACTS OF JAPAN vol. 018, no. 458 (E-1596), 25 August 1994 (1994-08-25) & JP 06 150868 A (FUJITSU LTD), 31 May 1994 (1994-05-31) abstract	1-39, 56-67
A	US 6 028 662 A (STURANS MARIS A ET AL) 22 February 2000 (2000-02-22) column 2, line 12 - line 17	1-39, 56-67
A	SOLECKY E ET AL: "Three dimensional top down metrology: a viable alternative to AFM or cross section?" METROLOGY, INSPECTION, AND PROCESS CONTROL FOR MICROLITHOGRAPHY XV, SANTA CLARA, CA, USA, 26 FEB1 MARCH 2001, vol. 4344, 2001, pages 366-376, XP001191175 Proceedings of the SPIE - The International Society for Optical Engineering, 2001, SPIE-Int. Soc. Opt. Eng, USA ISSN: 0277-786X the whole document	1-39, 56-67



PCT/US 03/38140

Box I Observations where certain claims were found unsearchable (Continuation of item 1 of first sheet)
This International Search Report has not been established in respect of certain claims under Article 17(2)(a) for the following reasons:
Claims Nos.: because they relate to subject matter not required to be searched by this Authority, namely:
Claims Nos.: because they relate to parts of the International Application that do not comply with the prescribed requirements to such an extent that no meaningful international Search can be carried out, specifically:
3. Claims Nos.: because they are dependent claims and are not drafted in accordance with the second and third sentences of Rule 6.4(a).
Box II Observations where unity of invention is lacking (Continuation of item 2 of first sheet)
This International Searching Authority found multiple inventions in this international application, as follows:
see additional sheet
1. As all required additional search fees were timely paid by the applicant, this international Search Report covers all searchable claims.
2. As all searchable claims could be searched without effort justifying an additional fee, this Authority did not invite payment of any additional fee.
3. As only some of the required additional search fees were timely paid by the applicant, this International Search Report covers only those claims for which fees were paid, specifically claims Nos.:
4. No required additional search fees were timely paid by the applicant. Consequently, this International Search Report is restricted to the invention first mentioned in the claims; it is covered by claims Nos.:
Remark on Protest The additional search fees were accompanied by the applicant's protest. X No protest accompanied the payment of additional search fees.

International Application No. PCT/ US 03/38140

FURTHER INFORMATION CONTINUED FROM PCT/ISA/ 210

This International Searching Authority found multiple (groups of) inventions in this international application, as follows:

1. claims: 1-39,51-67

Method for determining an angular deviation of a charged particle beam

2. claims: 40-50

Method for calibrating a charged particle beam system



Information on patent family members

PCT/US 03/38140

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